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DEC 23 2002 IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
TECHNOLOGY CENTER 2800 -----000:0:000-----

Application of :  
Akira YONEZAWA :  
Serial No. 09/978,258 : Group Art Unit - 2832  
Filed: October 15, 2001 :  
For: ELECTROMAGNETIC FIELD :  
SUPERIMPOSED LENS AND :  
ELECTRON BEAM DEVICE :  
USING THIS ELECTRO- :  
MAGNETIC FIELD SUPER- :  
IMPOSED LENS :  
: Docket No. S004-4416

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COMMISSIONER OF PATENTS AND TRADEMARKS  
Washington, DC 20231

PRELIMINARY AMENDMENT

S I R:

In order to place this application in better condition for a complete examination on the merits, applicant preliminarily amends his application as follows:

IN THE SPECIFICATION:

Please replace the paragraph beginning at page 1, line 8, with the following rewritten paragraph:

--In order to perform inspection or observation of the shape of a fine pattern using an electron beam device,

12/19/2002 NMOHMMH1 00000029 09978258

01 FC:1202  
02 FC:1201

180.00 DF  
64.00 DF

MAILING CERTIFICATE ON  
LAST PAGE